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| <input type="checkbox"/> | L4 | L2 and (first with anneal\$3) and (second with anneal\$3) | 200 |
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| | | ((wafer or substrate) with bond\$3) and ((heat\$3 or anneal\$3 or thermal\$4) | |
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L9 and (thermal adj budget)

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L10 L9 and (thermal adj budget) 29 L10L9 smart adj cut 568 L9

DB=USPT; PLUR=YES; OP=OR

L8 6828216.pn. 1 L8L7 6335258.pn. 1 L7L6 L5 and (split\$4 or separat\$4 or cleav\$4 or detach\$4 or delaminat\$5) 317 L6L5 L4 and (lower or less) 362 L5L4 L3 and thermal 397 L4L3 L2 and (hydrogen or ion) 487 L3L2 L1 and temperature and time 721 L2L1 438/4,455,458.ccls. 1223 L1

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| <input type="checkbox"/> | <p>4. Performance characteristics of Yardney lithium-ion cells for the Mars 2001 Lander application Smart, M.C.; Ratnakumar, B.V.; Whitcanacka, L.; Surampudia, S.; Lowry, L.; Gitzendanner, R.; Marsh, C.; Pu Marsh, R.; Energy Conversion Engineering Conference and Exhibit, 2000. (IECEC) 35th Intersociety Volume 1, 24-28 July 2000 Page(s):629 - 637 vol.1 AbstractPlus Full Text: PDF(784 KB) IEEE CNF</p> |
| <input type="checkbox"/> | <p>5. Plasma-assisted InP-to-Si low temperature wafer bonding Pasquariello, D.; Hjort, K.; Selected Topics in Quantum Electronics, IEEE Journal of Volume 8, Issue 1, Jan.-Feb. 2002 Page(s):118 - 131 AbstractPlus References Full Text: PDF(443 KB) IEEE JNL</p> |
| <input type="checkbox"/> | <p>6. Optoelectronic refractive index measurements: application to smart processing Cusano, A.; Cutolo, A.; Giordano, M.; Nicolais, L.; Sensors Journal, IEEE Volume 3, Issue 6, Dec. 2003 Page(s):781 - 787 AbstractPlus References Full Text: PDF(441 KB) IEEE JNL</p> |